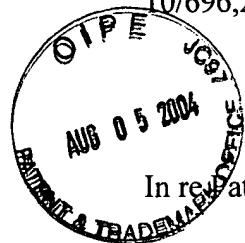


## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Patent Application of  
Jon Opsal

Application No.: 10/696,269

Filed: October 29, 2003

For: DETECTOR CONFIGURATIONS FOR  
OPTICAL METROLOGY

Confirmation No.: 6485

Group Art Unit: 2877

Examiner: Hoa Q. Pham

**RESPONSE TO OFFICE ACTION**  
**MAILED MAY 6, 2004**

353 Sacramento Street, Suite 2200  
San Francisco, CA 94111  
(415) 772-4900

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 2, 2004.  
STALLMAN & POLLOCK LLP

Dated: 08/2/2004 By: Georgia L. Stith

Georgia L. Stith

M/S AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed May 6, 2004, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.